

AUG 1 3 2004 P. AUG 1 20

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

AXEL PREUSSE MARKUS NOPPER HOLGER SCHÜHRER

Serial No.: 10/747,722

Filed: December 29, 2003

For: METHOD OF REDUCING WAFER

CONTAMINATION BY REMOVING UNDER-METAL LAYERS AT THE

for which the one-month date for response is August 28, 2004.

WAFER EDGE

Examiner: Edward J. Wojciechowicz

Group Art Unit: 2815

Att'y Docket: 2000.109700/DE0351

Customer No.: 23720

RESPONSE TO RESTRICTION REQUIREMENT DATED JULY 28, 2004

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

CERTIFICATE OF MAILING

I hereby certify that this paper or fee is being deposited with the United States Postal Service with sufficient postage as "FIRST CLASS MAIL" addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, this 9th day of August, 2004.

This paper is submitted in response to the Restriction Requirement dated July 28, 2004,

In response to the restriction requirement which the Examiner imposed, Applicants elect, with traverse, to prosecute claims 1-18, *i.e.*, the Group II claims.

It is believed that no fee is due; however, should any fees under 37 C.F.R. §§ 1.16 to 1.21 be required for any reason relating to this document, the Director is authorized to deduct said fees from Advanced Micro Devices, Inc. Deposit Account No. 01-0365/DE0351. In the event the monies in that account are insufficient, the Director is authorized to withdraw funds from Williams, Morgan & Amerson, P.C. Deposit Account No. 50-0786/2000.109700.

The Examiner is invited to contact the undersigned attorney at (713) 934-4055 with any questions, comments or suggestions relating to the referenced patent application.

Respectfully submitted,

WILLIAMS, MORGAN & AMERSON

CUSTOMER NO. 23720

Date: August 9, 2004

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